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FTO/SB/21 (08-03)

			Applica	ition Number	10/020,46	1
	SMITTAL		Filing C	ate	December	14, 2001
FORM		First Na	amed Inventor	M'Saad, H	ichem	
(to be used for all correspondence after initial filing)		Art Uni	t	1731		
			Examir	ner Name	Hoffmann,	John M.
Total Number of Pages in This Submission		Attorne	ey Docket Number	A6123/T43	3700	
ENCLOSURES (Check all that apply)						
Fee Transmittal F	orm	☐ Drawin	g(s)		After Allowance Communication to Group	
Fee Attache	d	Licensi	ng-related	i Papers		Communication to Board of Appeals erferences
Amendment/Repl	у	Petition	ì			Communication to Group (Appeal Brief, Reply Brief)
After Fingl			n to Conve onal Appli		Proprie	etary Information
Affidavits/de	claration(s)			ey, Revocation espondence Address	Status Letter	
Extension of Time Request		☐ Termin	nal Disclaimer			Enclosure(s) Identify below):
Express Abandonment Request			uest for Refund Number of CD(s)		Return Postcard, copies of elevan (11) cited references	
Certified Copy of Priority Document(s) Re		Rema	rks	The Commissioner is a Account 20-1430.	authorized to	charge any additional fees to Deposit
Response to Missincomplete Applie				l		
	o Missing Parts R 1.52 or 1.53					
				ICANT, ATTORNEY,	OR AGEN	Г
Firm Townsend and Townsend a or Patrick M. Boucher			ind Crew		o. 44,037	
Signature Satul No.						
Date 2004 May 24						
CERTIFICATE OF TRANSMISSION/				TRANSMISSION/M	AILING	
I hereby certify that this co as first class mail in an en	rrespondence is being velope addressed to: C	facsimile tran	smitted to to for Patents,	he USPTO or deposited wit , P.O. Box 1450, Alexandria	h the United St a, VA 22313-14	ates Postal Service with sufficient postage 50 on the date shown below.
Typed or printed name	e Nicole Wart	ell				
Signature Supplement		Jul	\supset	Date	5/24/04	

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TOWNSEND and TOWNSEND and CREWILLP

Nicole Wartell

PATENT

Attorney Docket No.: A6123/T43700 AMAT No.: 006123/DD/HDP/JW

TTC No.: 016301-043700US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

HICHEM M'SAAD et al.

Application No.: 10/020,461

Filed: December 14, 2001

For: METHOD OF MANUFACTURING

AN OPTICAL CORE

Examiner: Hoffmann, John M.

Art Unit: 1731

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37

CFR §1.97 and §1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no

HICHEM M'SAAD et al. Application No.: 10/020,461

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representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Patrick M. Boucher Reg. No. 44,037

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Substitute for form 1449 FTO

INFORMATION DISCLOSURE

STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

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	Complete if Known
Application Number	10/020,461
Filing Date	December 14, 2001
First Named Inventor	M'Saad, Hichem
Art Unit	1731
Examiner Name	Hoffmann, John M.
Attorney Docket Number	A6123/T43700

	U.S. PATENT DOCUMENTS+						
		Document Number					
Examiner Initials*	Cite No. ¹	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	A1	US-4,557,561	12-10-1985	Schneider et al.			
	A2	US-6,154,582	11-28-2000	Bazylenko et al.			
	A3	US-6,194,038 B1	02-27-2001	Rossman			
	A4	US-6,451,686 B1	09-17-2002	Ngai et al			
	A5	US-2003/0113085 A1	06-19-2003	M'Saad et al.			
	A6	US-6,705,124 B2	03-16-2004	Zhong et al.			
	A7	US 2004/0079118 A1	04-29-2004	M'Saad et al.			
	A8	US-			-		

	FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Fore	eign Patent Doo Number ⁴	cument Kind Code ⁸ (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T [®]
	B1							
	B2							

Examiner Signature	Date Considered	

Substitute for form 1449B/F Complete if Known 10/020,461 Application Number INFORMATION DISCLOSURE Filing Date December 14, 2001 STATEMENT BY APPLICANT First Named Inventor M'Saad, Hichem Art Unit 1731 (use as many sheets as necessary) Examiner Name Hoffmann, John M. 2 Sheet of Attorney Docket Number A6123/T43700

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T 2
	C1	MATTHEWS, MANYALIBO J. et al. "Characterization of phosphosilicate thin films using confocal Raman microscopy" Review of Scientific Instruments, May 2000, pp. 2117-2120, Vol. 71, No. 5, American Institute of Physics.	
	C2	VERBEEK, B.H. et al. "Integrated Four-Channel Mach-Zehnder Multi/Demultiplexer Fabricated with Phosphorous Doped SiO2 Waveguides on Si" Journal of Lightwave Technology, June 1988, pp. 1011-1015, Vol. 6, No. 6, IEEE.	
	СЗ	VALETTE, S. et al. "Si-Based Integrated Optics Technologies" Solid State Technology, February 1989, pp. 69-75.	
	C4	VALETTE, S. et al. "State of the art of integrated optics technology at LETI for achieving passive optical components" Journal of Modern Optics, 1988, pp. 993-1005, Vol. 35, No. 6.	
	C5		

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.